ELSEVIER

Contents lists available at ScienceDirect

Applied Surface Science

journal homepage: www.elsevier.com/locate/apsusc



X-ray photoelectron spectroscopy of select multi-layered transition metal carbides (MXenes)



Joseph Halim^{a,b,c}, Kevin M. Cook^{d,*}, Michael Naguib^e, Per Eklund^c, Yury Gogotsi^{a,b}, Johanna Rosen^c, Michael W. Barsoum^{a,c}

- ^a Department of Materials Science & Engineering, Drexel University, Philadelphia, PA 19104, USA
- ^b A.J. Drexel Nanomaterials Institute, Drexel University, Philadelphia, PA 19104, USA
- c Thin Film Physics Division, Department of Physics, Chemistry and Biology (IFM), Linköping University, SE-583 31 Linköping, Sweden
- ^d Materials Engineering Division, Naval Air Systems Command, Patuxent River, MD 20670, USA
- ^e Materials Science and Technology Division, Oak Ridge National Laboratory, Oak Ridge, TN 37831, USA

ARTICLE INFO

Article history: Received 20 August 2015 Received in revised form 2 November 2015 Accepted 7 November 2015 Available online 1 December 2015

Keywords: MXene XPS Metal carbides

ABSTRACT

In this work, a detailed high resolution X-ray photoelectron spectroscopy (XPS) analysis is presented for select MXenes—a recently discovered family of two-dimensional (2D) carbides and carbonitrides. Given their 2D nature, understanding their surface chemistry is paramount. Herein we identify and quantify the surface groups present before, and after, sputter-cleaning as well as freshly prepared vs. aged multilayered cold pressed discs. The nominal compositions of the MXenes studied here are $Ti_3C_2T_x$, Ti_2CT_x , Ti_3CNT_x , Nb_2CT_x and $Nb_4C_3T_x$, where T represents surface groups that this work attempts to quantify. In all the cases, the presence of three surface terminations,—O,—OH and —F, in addition to OH-terminations relatively strongly bonded to H_2O molecules, was confirmed. From XPS peak fits, it was possible to establish the average sum of the negative charges of the terminations for the aforementioned MXenes. Based on this work, it is now possible to quantify the nature of the surface terminations. This information can, in turn, be used to better design and tailor these novel 2D materials for various applications.

Published by Elsevier B.V.

1. Introduction

Two-dimensional (2D) materials have become a major focus of the scientific community due to an unprecedented combination of properties and behaviors that result from their reduced dimensionality. For example, single-layer graphene – the most explored 2D material – was shown to have high conductivity at room temperature, while transmitting 97.7% of visible light [1–3]. In addition to graphene, other 2D materials have been reported, such as hexagonal boron nitride (BN) [4], transition metal dichalcogenides (TMD) [5], such as MoS₂ [6,7], and metal oxides and hydroxides [8]. Most 2D solids are typically strongly bonded within the atomic sheets that, in turn, are held together in stacks by weak inter-layer forces. As may be expected, the latter allow for the intercalation of molecules between the layers, as well as, the delamination, or separation of the layers into individual flakes [9].

By definition, both stacked 2D layers and individual 2D flakes are almost entirely comprised of surface. As such, their surface

chemistries have a critical influence on their properties and characteristics. For example, hydrophobic graphene can be rendered hydrophilic by oxidizing it to form graphene oxide [10]. The determination of the surface chemistry is therefore an integral component in the characterization and understanding of 2D materials [11–16].

In 2011, a large new family of 2D materials - layered transition metal carbides and carbonitrides, we labeled MXenes was discovered [17]. These materials are produced from layered ternary carbides and nitrides known as the $M_{n+1}AX_n$, or MAX, phases [18], which, in turn, are a large (70+) group of layered hexagonal compounds, where M is an early transition metal, A is an A-group element (mostly groups 13 and 14), X is C or/and N and n is 1 to 3. To form the corresponding MXene, the A-layers are selectively etched using hydrofluoric acid, HF, or fluoride salts and inorganic acids, such as hydrochloric acid, HCl [19]. When the Al-layers are etched, they are replaced by surface terminations, such as -0, -OH, and -F [20-22], resulting in weakly bound stacks of 2D sheets with a $M_{n+1}X_nT_x$ composition [23], where T_x stands for surface termination [20–22]. To date, the following MXenes have been reported: Ti₃C₂T_x, Ti_2CT_x , Nb_2CT_x , V_2CT_x , $(Ti_{0.5},Nb_{0.5})_2CT_x$, $(V_{0.5},Cr_{0.5})_3C_2T_x$, Ti_3CNT_x , $Ta_4C_3T_x$, $Nb_4C_3T_x$, $Mo_2TiC_2T_x$, and $Mo_2Ti_2C_3T_x$ [17,20,21,24,25].

^{*} Corresponding author. Tel.: +1 3013425314. E-mail address: kevin.m.cook1@navy.mil (K.M. Cook).

Studies on these materials have included their possible use in energy storage systems, such as lithium ion batteries [21,26–28], lithium ion capacitors [29], aqueous pseudocapacitors [19,30], and transparent conductive films [22]. We have also shown that it is possible to intercalate various small organic molecules between the layers [27]. Very recently, we also demonstrated that Ti₃C₂T_x not only adsorbed select organic molecules, but could also lead to their photocatalytic decomposition in aqueous environment [31]. The same compound also can be used for various applications from removing Pb from water to supporting catalysts [32,33]. The $Ti_3C_2T_x$ produced using a mixture of LiF and HCl has clay-like properties, and swelled in volume when hydrated. When used as an electrode in a supercapacitor, volumetric capacitance of the order of 900 F/cm³ was measured for this material, while a volumetric capacitance of about 530 F/cm³ was measured when the material was used in flexible nanocomposite polymer films [19,34]. Furthermore, exfoliated MXene particles were shown to delaminate and form a suspension in water after intercalation with several compounds, such as tetrabutylammonium hydroxide and isopropylamine [35,36]. Common to all of these applications is a need for proper detection and understanding of the functional surface groups present, as they in many cases, largely determine performance.

Given the crucial and vital importance of surface chemistry on MXene properties and applications, it is somewhat surprising that, to date, these surfaces have not been systematically characterized. This paper is a first serious attempt to do so. Herein, we carefully study the surface chemistries of five different MXenes by XPS; the ultimate goal being the building a library of data that can be used to further understand these intriguing materials. XPS is an excellent tool for such studies since it can be used to determine the surface chemical compositions and the chemical states of the various species. By their very nature, nonoxide 2D materials, such as silicene, germanene, phosphorene [37], and transition metal dichalcogenides [38], are prone to oxidation. The same is true for MXenes such as $Ti_3C_2T_x$ and Ti_2CT_x [39–42]. It follows that an important aim of this work was to probe the oxidation products of the various MXene chemistries. To that effect, we used XPS to examine all the Ti-containing MXenes both directly after synthesis, and after samples were stored in air, for about 12 months. We henceforth refer to the fresh MXene samples as "as-prepared," or "ap- $Ti_3C_2T_x$," for example. We refer to the stored samples as "aged," or "ag- $Ti_3C_2T_x$," for

A comparison of the XPS spectra of as-prepared MXene samples and those stored in air, provides valuable information concerning their propensity to oxidation. The results presented herein show that, despite being stored in air for 12 months, flakes of the Ti-based compositions, did not appear – aside from a shallow (\sim 10 to 50 nm) oxidized outer layer – to be unduly oxidized. The pressed Nb₂CT_x and Nb₄C₃T_x discs were also analyzed both directly after synthesis, and after storing in air. In this case, the samples were stored for about a month before making the measurements. Given the different aging times, between the Ti- and Nb-containing materials we cannot draw any conclusions as to which is more susceptible to oxidation. The information obtained, however is still valuable since information on changes in oxidation species is obtained nonetheless

In previous work, the surfaces of $Ti_3C_2T_x$, Nb_2CT_x and V_2CT_x were analyzed by XPS [17,21] in order to better understand the role of surface terminations and intercalants on energy storage systems [27], dye adsorption [31], and transparent conductive thin films [22]. In this work, we report on more systematic measurements on $Ti_3C_2T_x$ and Nb_2CT_x , and extend them to Ti_2CT_x , Ti_3CNT_x and $Nb_4C_3T_x$.

2. Materials and methods

Sample synthesis details can be found in the Supplementary materials Section S1 along with other information on experimental details and additional data

2.1. X-ray photoelectron spectroscopy analysis

XPS was performed using a surface analysis system (Kratos AXIS Ultra DLD, Manchester, U.K.) using monochromatic Al- K_{α} (1486.6 eV) radiation for all the aged samples. The details of XPS measurements for as-prepared samples are shown in the Supplementary materials (See Section S4 for details). The cold-pressed samples were mounted on double-sided tape and grounded to the sample stage with copper contacts. The X-ray beam irradiated the surface of the samples at an angle of 45°, with respect to the surface and provided an X-ray spot size of $300 \times 800 \,\mu m$. The electron energy analyzer accepted the photoelectrons perpendicular to the sample surface with an acceptance angle of $\pm 15^{\circ}$. Charge neutralization was performed using a co-axial, low energy ($\sim 0.1 \text{ eV}$) electron flood source to avoid shifts in the recorded binding energy, BE. XPS spectra were recorded for F1s, O1s, C1s, Al2p, Ti2p, and Nb 3d, as well as N 1s for the Ti_3CNT_x composition. The analyzer pass energy used for all of the regions was 20 eV with a step size of 0.1 eV, giving an overall energy resolution better than 0.5 eV. The BE scale of all XPS spectra was referenced to the Fermi-edge (E_F) , which was set to a BE of zero eV. Normalization of all spectra was performed at the background on the low-BE side of the main peak/peaks.

The quantification, using the obtained core-level intensities, was carried out using CasaXPS Version 2.3.16 RP 1.6. Peak fitting of corelevel spectra was performed using IGOR Pro, Version 6.22A. Prior to peak fitting, the background contributions were subtracted using a Shirley function. For all $2p_{3/2}$ and $2p_{1/2}$ components and $3d_{5/2}$ and $3d_{3/2}$ components, the intensity ratios of the peaks were constrained to be 2:1 and 3:2, respectively. A detailed description of the curve fitting process can be found in Supplementary materials, Section S4, including information regarding the choice of lineshapes and constraints used to quantify the spectra.

The first step in this study was to establish the chemical nature of these compounds before, and after, Ar⁺ sputtering for 600 s using a 4 keV Ar^+ beam raster of $2 \times 2 \text{ mm}^2$ over the probed area. Since all samples were in the form of compressed powder discs, comprised of 2D-flakes with high surface areas and varied contours, they presented a challenge. However, obtaining spectra before sputtercleaning allowed for the characterization of the outermost layers of these pressed discs. By their very nature, the un-sputtered surfaces inherently contain a much larger amount of contamination, from ambient atmosphere and/or as a result of processing. Nevertheless, such an analysis is crucial for applications that are sensitive to the identity of species in the outermost layers, such as photocatalysis. As noted above they also shed critically important light on the stability of these compounds vis-à-vis oxidation. We also note in passing that the long time between processing and analysis was in part to understand the stability of the MXene flakes to long-term oxidation.

As will become evident shortly, these systems are non-trivial to characterize, since a relatively large number of surface terminations exist. To render the discussion more transparent, henceforth, each type of termination will be depicted by Roman numerals, as shown in Fig. 1 and Table 1. In Fig. 1, oxygen atoms are colored red, fluorine blue, hydrogen white and the M atoms – Ti and Nb – yellow. Table 1 summarizes the moieties assumed in the MXenes and their peak positions. When taken from the literature, the references are cited.

In reference to Fig. 1, the following is how they are defined:

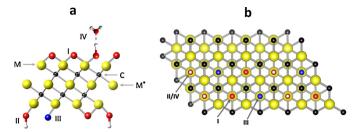


Fig. 1. Side (a) and top (b) view schematics of a $M_3X_2T_x$ structure showing various M atoms and their terminations. Number I refers to a M atom bonded to an O atom, *i.e.* an oxo group; II to OH; III, to a M atom directly bonded to a F-atom; IV, to an M atom bonded to OH, that, in turn, is strongly bonded to a H₂O molecule. In this schematic, M atoms are colored yellow, X, black, O, red, H white and F, blue (not to scale). M atoms only bonded to C atoms are designated, M'. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

Table 1Summary of moieties assumed to exist in MXenes and their characteristic energies. Roman numerals refer to the various moieties shown in Fig. 1.

| Moiety | Species | Binding energy [eV] | Ref. |
|--------|-----------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------|---------------------------|
| I | $C-Ti-O_x$ $C-Nb-O_x$ | 531.3 (O 1s region) 531.0 (O 1s region) | [43] This work |
| II | C — Ti — $(OH)_x$ C — Nb — $(OH)_x$ | 531.7 (O 1s region) 531.6 (O 1s region) | [43] This work |
| III | $\begin{array}{l} \textbf{C-T}iF_x\\ \textbf{CN}bF_x\\ \textbf{N}b^\dagger \end{array}$ | 685.2 (F 1s region) 685.3 (F 1s region) 203.1 [3d5/2]; 205.9 [3d5/2] (Nb 3d region) | [44] [45] This work |
| | Nb—C ^v Nb [*] | 282.3 (C 1s region) 203.5 [3d5/2]; 206.3 [3d3/2] (Nb 3d region) | This work [46,47] |
| IV | H ₂ O _{ads} [Ti-case] H ₂ O _{ads} [Nb-case] | 533.3 (O 1s region) 533.3 (O 1s region) | [43] This work |

 $^{^{}v}C$ bound to Nb^{\ddagger} .

- (i) Moiety I (labeled I in Fig. 1) refers to M atoms bonded to C atoms and one oxygen atom, e.g. Ti₃C₂O_x or Nb₂CO_x.
- (ii) Moiety II refers to M atoms bonded to C atoms and an OH group, e.g. Ti₃C₂(OH)_x or Nb₂C(OH)_x.
- (iii) Moiety III refers to M atoms bonded to C and F atoms, e.g. $Ti_3C_2F_X$ or Nb_2CF_X .
- (iv) Moiety IV refers to M atoms bonded to OH-terminations that in turn are relatively strongly physisorbed to water molecules forming OH—H₂O complexes (shown as moiety IV in Fig. 1), viz. Ti₃C₂OH—H₂O [43]. These will be henceforth be referred to as H₂O_{ads}.

The M atoms that are bonded to C atoms alone – e.g. those in the central layers of the n>1 MXene flakes – will be referred to by an asterisk, or M*. In the Ti case, we could not differentiate between moiety I and Ti* atoms and thus both are labeled I. In the Nb₄C₃T_x case, there was a clear distinction between the Nb* atoms and moiety I. However, one complication with the Nb-containing MXenes is Ar beam damage. A peak – possibly emanating from a Nb atom bonded to one less C-atom than its neighbors – will henceforth be referred to as Nb ‡ . A peak arising from a C atom bonded to Nb ‡ and next to a vacant C site will henceforth be referred to as Nb—C $^{\text{v}}$. The fraction of the latter species after sputtering was <10%.

To recapitulate, for the Ti flakes, the following moieties were assumed to exist: I, II, III and IV. For the Nb compositions, moieties

I, II, III, IV, Nb*, NbV and Nb‡ (after sputtering only) were invoked. Table 1 lists the energies associated with each termination. In addition a number of peaks associated with TiO2 and Nb2O5, as separate species due to oxidation were also identified. We also identified M atoms that are bonded to O atoms alone – *i.e.* in oxide form – that are, in turn, bonded to a F-atom, *i.e.* $\text{TiO}_{2-x}F_x$ or $\text{NbO}_{1-x}F_x$, as separate oxyfluoride species. It is with this in mind that we stress that the sheer chemical complexity (from internal moieties, adventitious organic species to oxidation products) of MXene systems can cause ambiguity within spectra. The existence of so many chemical species necessitates the inclusion of a large number of fitting components in XPS analysis in order to account for their presence. Having established these fitting schemes as a robust system has advantages, however, since as shown here it allows us to track any shifts in surface terminations, such as oxidation, with time.

3. Results

At the outset, it is important to note that some binary carbide impurity phases were present in the initial MAX phase powders. Based on XRD patterns of the parent MAX phases (not shown) we estimate that 15 mol% TiC impurity phase was present in Ti₂AlC; 15 mol% of TiC_yN_z in Ti₃AlCN; 20 mol% of Nb₄AlC₃ in Nb₂AlC and 5 mol% of NbC in Nb₄AlC₃. In all results reported herein, the presence of these binary carbides were accounted for, and subtracted from the chemical compositions – more details are found in Supplementary materials Section S3.

Since the most important contribution of this work is assigning – in a comprehensive and consistent manner – the various energy peaks to different moieties, in this section we focus on the component peak-fitting (deconvolution) of XPS spectra for the preand post-sputter cleaned ap- ${\rm Ti}_3C_2{\rm T}_x$ and the sputter-cleaned ag- ${\rm Nb}_4{\rm C}_3{\rm T}_x$ as being representative of the chemical species present in all MXenes studied herein. The XPS spectra and peak-fits for the other MXenes can be found in supplementary material (see Section S5). In addition, we measured the XPS spectra of all parent MAX phases after sputtering (see Supplementary material Section S6 and Figs. S12–S16).

3.1. $Ti_3C_2T_x$ (Fig. 2; Tables 2 and 3)

Fig. 2a–d plot, respectively, the spectra for Ti, C, O and F for pre-sputter-cleaned ap- $Ti_3C_2T_x$, together with their peak-fits. The respective spectra, after sputtering, are plotted in Fig. 2e–g. The peak positions obtained from the fits are summarized in Tables 2 and 3 for the pre- and post-sputtered ap- $Ti_3C_2T_x$ samples, respectively.

3.1.1. Ti 2p region

The Ti 2p region for the pre-sputtered ap- $Ti_3C_2T_x$ sample (Fig. 2a), was fit by the components listed in column 5 in Table 2. The majority of the species are Ti atoms (Ti, Ti^{2+} , Ti^{3+}), that belong to moieties I, II, and/or IV and $Ti_3C_2F_x$, viz. moiety III. These comprise 93% of the photoemission in the Ti 2p region. The same region, for the sputtered ap- $Ti_3C_2T_x$ sample (Fig. 2e, Table 2), was fit by the same moities (I, II, and/or IV, and III). In this case, they comprise 98% of the photoemission in the Ti 2p region. It is worth noting that similar oxidation states for Ti reported here, viz. Ti^{2+} and Ti^{3+} , were reported for TiC [48].

For the pre-sputtered ag- $Ti_3C_2T_x$ sample (see Fig. S2, Table S3), the moieties I, II, or IV, and III comprise 77% of the Ti 2p region photoemission. After sputtering they comprise 83% (see Fig. S3, Table S4). In other words, for the pre-sputtered ag- $Ti_3C_2T_x$ sample, almost a quarter of the Ti 2p region belongs to TiO_2 and $TiO_{2-x}F_x$. This percentage decreases slightly after sputtering.

[‡] Nb near a C vacancy.

^{*} Interior Nb bound to only C (no surface terminations).

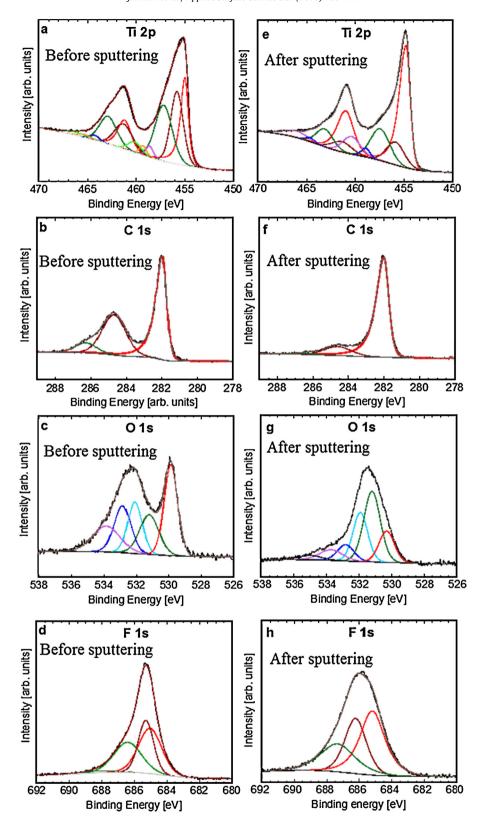


Fig. 2. Component peak-fitting of XPS spectra for ap- $Ti_3C_2T_x$, (a) Ti 2p, (b) C 1s, (c) O 1s, and (d) F 1s before sputtering and, (e) Ti 2p, (f) C 1s, (g) O 1s and, (h) F 1s after sputtering. The various peaks under the spectra represent various moieties assumed to exist. The results are summarized in Tables 2 and 3 for the pre and post-sputtering samples, respectively.

Note that the BE of the Ti $2p_{3/2}$ peaks in the ap-Ti₃C₂T_x sample decreases slightly, from 455.0 eV to 454.8 eV, upon sputtering. This decrease might be due to the introduction of defects and/or incorporated Ar ions due to sputtering, which

is a commonly observed for transition metal carbides [49]. For the ag- $Ti_3C_2T_x$ sample, the BE decreases from 455.2 eV to 454.9 eV upon sputtering. Note that the pre-sputtered BE of this peak increased by $0.2 \, \text{eV}$ after aging the sample,

Table 2XPS peak fitting results for ap- $Ti_3C_2T_x$ before sputtering. The numbers in brackets in column 2 are peak locations of $Ti\ 2p_{1/2}$; their respective full-widths at half maximum, FWHM, are listed in column 3 in brackets.

| Region | BE [eV] ^a | FWHM [eV] ^a | Fraction | Assigned to | Reference |
|-------------------------------------------|----------------------|------------------------|----------|-------------------------------------------------------------|------------|
| Ti 2p _{3/2} (2p _{1/2}) | 455.0 (461.2) | 0.8 (1.5) | 0.28 | Ti (I, II or IV) | [48,50] |
| 1-1-1 1-1-1 | 455.8 (461.3) | 1.5 (2.2) | 0.30 | Ti ²⁺ (I, II, or IV) | [48] |
| | 457.2 (462.9) | 2.1 (2.1) | 0.32 | Ti ³⁺ (I, II, or IV) | [48] |
| | 458.6 (464.2) | 0.9 (1.0) | 0.02 | TiO ₂ | [55,56] |
| | 459.3 (465.3) | 0.9 (1.4) | 0.03 | $TiO_{2-x}F_x$ | [57] |
| | 460.2 (466.2) | 1.6 (2.7) | 0.05 | $C-Ti-F_x$ (III) | [54] |
| C 1s | 282.0 | 0.6 | 0.54 | C — Ti — T_x (I, II,III, or IV) | [48,50] |
| | 284.7 | 1.6 | 0.38 | C—C | [58] |
| | 286.3 | 1.4 | 0.08 | $CH_x/C-O$ | [58] |
| 0 1s | 529.9 | 1.0 | 0.29 | TiO ₂ | [43,56] |
| | 531.2 | 1.4 | 0.18 | C—Ti—O _x (I) and/or OR ^b | [43,53] |
| | 532.0 | 1.1 | 0.18 | C—Ti—(OH) _x (II) and/or OR ^b | [43,53] |
| | 532.8 | 1.2 | 0.19 | Al ₂ O ₃ and/or OR ^b | [53,59,60] |
| | 533.8 | 2.0 | 0.17 | H ₂ O _{ads} (IV) and/or OR ^b | [43,53] |
| F 1s | 685.0 | 1.7 | 0.38 | $C-Ti-F_x$ (III) | [54] |
| | 685.3 | 1.1 | 0.29 | $TiO_{2-x}F_x$ | [57] |
| | 686.4 | 2.0 | 0.30 | AlF_x | [57] |
| | 688.3 | 2.0 | 0.02 | $Al(OF)_x$ | [59] |

^a Values in parenthesis correspond to the $2p_{1/2}$ component.

Table 3 XPS peak fitting results for ap- $Ti_3C_2T_x$ after sputtering. Numbers in brackets in column 2 are peak locations of $Ti_3C_2T_x$; their full-widths at half maximum, FWHM, are listed in column 3 in brackets.

| Region | BE [eV] | FWHM [eV] | Fraction | Assigned to | Reference |
|-------------------------------------------|---------------|-----------|----------|-------------------------------------------------------------|------------|
| Ti 2p _{3/2} (2p _{1/2}) | 454.8 (461.0) | 1.0 (1.9) | 0.52 | Ti (I, II or IV) | [48,50] |
| x = /= · · · -/= · | 455.9 (461.5) | 2.2 (2.4) | 0.14 | Ti ²⁺ (I, II, or IV) | [48] |
| | 457.5 (463.2) | 2.3 (2.0) | 0.21 | Ti ³⁺ (I, II, or IV) | [48] |
| | 459.0 (464.7) | 1.0 (1.1) | 0.02 | TiO ₂ | [55,56] |
| | 460.4 (466.1) | 2.1 (2.9) | 0.11 | $C-Ti-F_x$ (III) | [44] |
| C 1s | 282.0 | 0.6 | 0.85 | C — Ti — T_x (I, II,III, or IV) | [48,50] |
| | 284.6 | 0.18 | 0.14 | C—C | [58] |
| | 286.5 | 1.4 | 0.01 | $CO \cdot H_x/C - O$ | [58] |
| 0 1s | 530.3 | 1.1 | 0.16 | TiO ₂ | [43,56] |
| | 531.2 | 1.2 | 0.39 | C—Ti—O _x (I) and/or OR ^b | [43,53] |
| | 531.9 | 1.1 | 0.24 | C—Ti—(OH) _x (II) and/or OR ^b | [43,53] |
| | 532.8 | 1.2 | 0.09 | Al ₂ O ₃ and/or OR ^b | [53,59,60] |
| | 533.7 | 1.7 | 0.08 | H ₂ O _{ads} (IV) and/or OR ^b | [43,53] |
| | 534.9 | 1.7 | 0.04 | $Al(OF)_x$ | [59] |
| F 1s | 685.2 | 1.8 | 0.44 | $C - Ti - F_x$ (III) | [44] |
| | 686.2 | 1.6 | 0.30 | AlF_x | [59] |
| | 687.3 | 2.5 | 0.26 | $Al(OF)_x$ | [59] |

 $^{^{\}text{a}}$ Values in parenthesis correspond to the $2p_{1/2}$ component.

indicative of the removal of electron density as the sample oxidized.

In general, the BEs for the Ti peaks of the $\text{Ti}_3\text{C}_2\text{T}_x$ samples (\approx 455 eV), are higher than the 454.6 eV value in the parent MAX phase, Ti_3AlC_2 (Fig. S13a) [50]. This shift is due to the replacement of the Al layers by more electronegative surface terminations such as O, OH and F.

3.1.2. C 1s region

The C 1s region (Fig. 2b) of the pre-sputtered ap-Ti₃C₂T_x sample was fit by three peaks. The largest (\approx 54% of the C 1s region), at a BE of 282.0 eV, corresponds to C—Ti—T_x (moieties I, II, III, and/or IV). After sputtering, the BEs do not change (compare Fig. 2b and f), but the fraction of this peak, however, increases from 54% to 85% after sputtering. Its energy is slightly higher than that of C in Ti₃AlC₂ (281.5–281.8 eV) [50] (see also Fig. S13b). This can possibly be attributed to defects introduced in the Ti—C layers due to the etching procedure.

The other two peaks correspond to graphitic C—C and CH_x or C—O (Fig. 2b and f and Tables 2 and 3). The former could be due to selective dissolution of Ti during etching, which can result in graphitic C—C formation [51]. The CH_x , and C—O species, on the other hand, likely result from the solvents used in the separation and drying processes and/or the exposure of the high-surface area material to the ambient atmosphere. Note that the percentages of C—C, CH_x and C—O decrease to about 15% of the photoemission in the C 1s region for the ap-Ti₃C₂T_x sample after sputtering. Not surprisingly, the concentration of these species (69%) in the ag-Ti₃C₂T_x sample before sputtering is the highest. That value drops to 13% after sputtering (see Supplementary materials Section S5.2),

3.1.3. O 1s region

The O 1s region for the pre-sputtered ap- $Ti_3C_2T_x$ sample (Fig. 2c), was fit by components corresponding to C–Ti– O_x (moiety I), C–Ti–(OH) $_x$ (moiety II), and H_2O_{ads} (moiety IV), which are the majority fractions (53%) of that region. The balance is in the form of

^b OR stands for organic compounds due to atmospheric surface contamination.

^b OR stands for organic compounds due to atmospheric surface contaminations.

 TiO_2 , $TiO_{2-x}F_x$, and Al_2O_3 (Column 5 in Table 2). After sputtering, the total fraction of the latter is reduced to 29%. Sputtering does not affect any of the BEs of the oxygen species in the ap- $Ti_3C_2T_x$ sample.

The O 1s region for the pre-sputtered ag- $Ti_3C_2T_x$ sample (Fig. S2c) was fit by the same components as above. However, in this case the content of TiO_2 , $TiO_{2-x}F_x$ and Al_2O_3 is 31%. (Column 4 in Table S3). A large contribution to this region is from organic contamination, which overlaps with, and obscures, many other peaks. After sputtering, the total fraction of these oxides increases slightly to 34%, largely because of the removal of organic contamination. Sputtering does not affect any of the BEs of the oxygen species in the ap- $Ti_3C_2T_x$ sample.

The BEs of moiety I in the ap- $Ti_3C_2T_x$ and ag- $Ti_3C_2T_x$ samples, before and after sputtering, ranged from 531 to 531.3 eV. These values are close to those of an O atom near to a vacant site in TiO_2 , *i.e.* a defective TiO_2 (531.5 eV) [43]. The peak for moiety II is located at BEs ranging from 531.7 to 532 eV, which is quite close to that of OH groups at bridging sites on TiO_2 [43]. The binding energy for moiety II shifts to a lower BEs upon aging and/or sputtering, which indicates that the local environment of such species is changed upon aging and/or sputtering

As discussed above, the H_2O_{ads} component (moiety IV) reflects the aqueous nature of the production of MXenes. The BE of its peak, for the pre- and post-sputtered ap- $T_{13}C_2T_x$ – at 533.8 and 533.7 eV, respectively – are quite close to each other and to that of water adsorbed on titania (533.5 eV) [43]. This BE is higher than that for the same component in the ag- $T_{13}C_2T_x$ sample pre- and post-sputtering, which are at 533.2 and 533.3 eV, respectively, (see Figs. S2c and S3c and Tables S3 and S4). This species has been observed for $T_{13}C_2T_x$, as well as other MXenes such as Nb_2CT_x and V_2CT_x [22,52]. The $AI(OF)_x$ species, present in ap- $T_{13}C_2T_x$ after sputtering, and ag- $T_{13}C_2T_x$ before, and after, sputtering is present as a by-product of the synthesis procedure. The presence of $AI(OF)_x$ after sputtering in ap- $T_{13}C_2T_x$ probably reflects inhomogeneities in the etched powders and/or less than perfect washing.

No useful quantitative information – as opposed to BEs – could be obtained from the O XPS spectra of the aged samples before sputtering because the fitted peaks in the 531 eV to 534 eV BE range overlaped with those of other organic compounds [53] whose concentration is non-trivial.

3.1.4. F 1s region

The major component in the F1s region (Fig. 2d) prior to sputtering for the ap- $Ti_3C_2T_x$ sample was C—Ti— F_x (*i.e.* moiety III in Fig. 1) at a BE of 685.0 eV. This BE is 0.1 eV higher than that of TiF_4 [54], a similar compound that should have a value close to that of the Ti—F bond in $Ti_3C_2F_x$. After sputtering, the BE increases to 685.2 eV (Fig. 2h, and Table 3).

Before sputtering of the ag-Ti₃C₂T_x sample, the BE of moiety III drops 0.2 eV (Fig. S2d and Table S3). After sputtering, the BE of this moiety, is identical to that of the ap-Ti₃C₂T_x (Fig. 2d and Table 2). All samples contained small fractions of TiO_{2-x}F_x, AlF_x and Al(OF)_x (Tables 2 and 3, Tables S3 and S4). The latter two are present as byproducts of the synthesis procedure, and their presence was confirmed by high-resolution XPS spectra in the Al 2p region (Fig. S2e).

3.2. $ag-Nb_4C_3T_x$ (Fig. 3; Table 4)

Fig. 3a–d plot the post-sputtered spectra for Nb, C, O and F, respectively, in the ag-Nb $_4$ C $_3$ T $_x$ sample, together with their peak fits. The results are summarized in Table 4.

3.2.1. Nb 3d region

The XPS spectra of this region (Fig. 3a) were fit by the corresponding components listed in column 5 in Table 4: Nb ‡ , Nb * , Nb (moieties I, II, and/or IV), and C—Nb—F $_X$ (moiety III). These species comprised 86% of the photoemission in the region, while the rest is assigned to the various oxides, NbO, NbO $_2$, NbO $_{1-x}F_x$ and Nb $_2$ O $_5$ and a nearly negligible unidentified component at a BE of 209.2 eV (only 1% of photoemission), which could be due to the effect of Ar sputtering.

The peak assigned to moieties I, II and/or IV has a BE of 203.8 eV, which is $0.4 \, \text{eV}$ lower than to its counterpart in Nb_4AlC_3 (Fig. S17a) and is $0.1 \, \text{eV}$ lower than of its counterpart in NbC [46,47]. Since this species corresponds to the two outer Nb layers, this decrease in BE is, again, due to the replacement of the Al layers by more electronegative surface terminations [46]. Conversely, the peak attributed to the two inner metal atom layers (Nb *) has a BE of 203.5 eV, which is $0.2 \, \text{eV}$ lower than that of its NbC counterpart (203.7 eV). This somewhat unexpected result suggests that the inner Nb atoms in

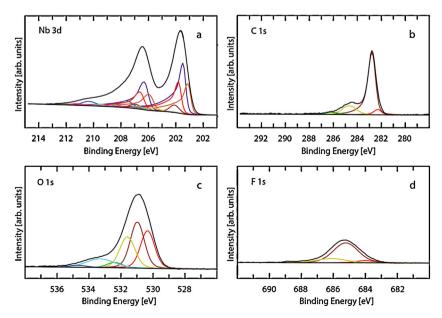


Fig. 3. Post Ar⁺-sputtering component peak-fitting of XPS spectra for, (a) Nb 3d, (b) C 1s, (c) O 1s and, (d) F 1s for ag-Nb₄C₃T_x sample. The various peaks represent various moieties assumed to exist. The results, after sputtering, are summarized in Table 4.

Table 4XPS peak fitting of results – shown in Fig. 3 – for ag-Nb₄C₃T_x after sputtering. The numbers in brackets in column 2 are peak locations of Nb $3d_{3/2}$; their full-widths at half maximum. FWHM. are listed in column 3 in brackets.

| Region | BE [eV] ^a | FWHM [eV] | Fraction | Assigned to | Reference |
|-------------------------------------------|----------------------|-----------|----------|-------------------|------------|
| Nb 3d _{5/2} (3d _{3/2}) | 203.1 (205.9) | 0.5 (0.7) | 0.23 | Nb [‡] | |
| -1- \ -1-7 | 203.5 (206.3) | 0.5 (0.7) | 0.38 | Nb* | |
| | 203.8 (206.6) | 0.5 (0.7) | 0.23 | Nb (I, II, or IV) | [46,47] |
| | 204.1 (206.9) | 0.8 (0.9) | 0.04 | NbO | [46,65,66] |
| | 205.6 (208.4) | 0.9 (1.0) | 0.02 | Nb(3+)—O | |
| | 206.7 (209.5) | 0.9 (1.0) | 0.02 | Nb(4+)—O | [46,65,66] |
| | 207.6 (210.4) | 0.9 (1.0) | 0.05 | Nb_2O_5 | [46,65,66] |
| | 208.4 (211.2) | 1.1 (1.2) | 0.02 | $C-Nb-F_x$ (III) | [45,66] |
| C 1s | 282.3 | 0.7 | 0.06 | Nb—C ^v | |
| | 282.8 | 0.7 | 0.74 | Nb—C | [61] |
| | 284.7 | 2.0 | 0.16 | C—C | [58] |
| | 286.1 | 2.0 | 0.04 | CH_x | [58] |
| 0 1s | 530.5 | 1.0 | 0.26 | Nb_2O_5 | [62-64] |
| | 531.0 | 1.0 | 0.32 | $C-Nb-O_x(I)$ | |
| | 531.6 | 1.1 | 0.24 | $C-Nb-(OH)_x(II)$ | |
| | 532.4 | 1.1 | 0.04 | Al_2O_3 | [59,60] |
| | 533.3 | 2.0 | 0.12 | H_2O_{ads} (IV) | |
| | 534.7 | 1.3 | 0.02 | $Al(OF)_x$ | [59] |
| F 1s | 684.0 | 1.4 | 0.06 | $NbO_{1-x}F_x$ | |
| | 685.3 | 1.4 | 0.75 | $C-Nb-F_x(III)$ | [45] |
| | 686.1 | 2.1 | 0.19 | AlF_x | [59] |

- $^{\rm a}$ Values in parenthesis correspond to the $3d_{3/2}$ component.
- 1 Nb near a C vacancy.
- * Interior Nb bound to only C (no surface terminations).

 $Nb_4C_3T_x$ take on additional electron density as compared to those in NbC

Both inner and outer Nb species exist before sputtering (Supplementary materials Section S5.4, Fig. S5 and Table S7). However, after sputtering a peak appears at a lower BE (203.1 eV), that was not present before. This peak can thus be attributed to sputter damage of Nb and/or Nb*.

3.2.2. C 1s region

The C 1s region (Fig. 3b) was fit by components corresponding to Nb–C $^{\rm v}$, C–Nb–T $_{\rm x}$ (I, II, or IV) and small fractions for graphitic C–C and CH $_{\rm x}$. The peak corresponding to Nb–C (I, II, III and/or IV) has a BE of 282.8 eV, which is slightly higher than that of Nb $_{\rm 4}$ AlC $_{\rm 3}$ (282.7 eV) (Fig. S16b) and NbC (281.8 eV) [61]. A peak at a lower BE (282.3 eV) is also present before, and after, sputtering, which can be attributed to a C near a vacancy, or defect, site (Nb–C $^{\rm v}$).

3.2.3. O 1s region

The spectra in this region (Fig. 3c) were fit by components corresponding to C–Nb– O_x (moiety I, 531.0 eV), C–Nb– $(OH)_x$ (moiety II, 531.6 eV) and H_2O_{ads} (moiety IV, 533.3 eV). These species comprise 68% of the O 1s region photoemission (Table 5). Note that the H_2O_{ads} peak position is located quite close to the same species discussed above for $Ti_3C_2T_x$, lending credence to its assignment. The remainder of the photoemission is fit by components corresponding to oxides of Nb_2O_5 (530.5 eV), Al_2O_3 (532.4 eV) and oxyfluorides of $Al(OF)_x$ (534.7 eV) [59,60,62–64]. These species are a result of surface oxidation and/or are by-products of the synthesis.

3.2.4. F 1s region

The spectra in this region (Fig. 3d) were fit by a peak corresponding to C–Nb– F_X (moiety III) that comprised 75% of the photoemission for the region. The other 25% of photoemission was fit by components for $NbO_{1-x}F_X$ and AlF_X (Table 4). The peak assigned to moiety III sits at a BE of 685.3 eV, which is slightly higher than the F 1s peak value for NbF_5 [45]. The peak for $NbO_{1-x}F_X$ is at 684.0 eV. The presence of AlF_X is confirmed by the appearance of a peak for this species in the Al 2p region (Fig. S6).

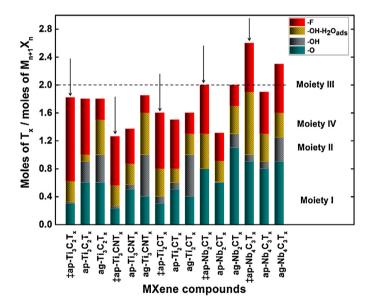


Fig. 4. Ratio of moles of terminations per $M_{n+1}X_n$ formula unit, obtained herein. The results obtained for columns labeled by arrows were obtained before sputtering; all the rest after Ar sputtering. The formulas for before sputtering are marked with ‡. Both as-prepared, ap, and after aging, ag, samples are shown. The hatched regions represent the total fraction of OH terminations; the ones with H_2O adsorbed are depicted in yellow. Note that if one termination is assumed per M atom, then in all cases the theoretical T_x number per formula unit is 2 given by the horizontal dashed line. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

3.3. Distributions of terminations

Fig. 4 plots the post-sputtered moles of the various T_x species (as derived from the fits of the non-metal spectral regions) per MXene formula unit (as derived from the fits of the metal spectral regions) for all samples examined herein. These same results, including the C-content, are also presented in Table 5 as chemical formulas. A perusal of these results shows that:

Table 5Summary of results obtained in this work. Entries labeled '‡' were determined from spectra before sputtering. The net negative charges on the terminations – assuming the charges of the oxygen atoms are -2, those on F and OH, -1 – are shown in brackets below the formulas.

| M_2XT_x | $M_3X_2T_x$ | $M_4X_3T_x$ |
|----------------------------------------------------------------------------------------------------------------------------------------------------------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------------|------------------------------------------------------------------------------------------------------------------------------------------------------------|
| [‡] ap-Ti ₂ C _{0.9} O _{0.3} (OH) _{0.1} (OH—H ₂ O _{ads}) _{0.4} F _{0.8} (1.9) | [‡] ap-Ti ₃ C ₂ O _{0.3} (OH) _{0.02} (OH—H ₂ O _{ads}) _{0.3} F _{1.2} (2.12) | †ap-Nb ₄ C _{2.6} O _{0.9} (OH) _{0.1} (OH—H ₂ O _{ads}) _{0.9} F _{0.7} (3.5) |
| ap-Ti ₂ C _{0.9} O _{0.5} (OH) _{0.1} (OH—H ₂ O _{ads}) _{0.2} F _{0.7} | ap-Ti ₃ C _{1.8} O _{0.6} (OH) _{0.3} (OH—H ₂ O _{ads}) _{0.1} F _{0.8} | ap-Nb ₄ C _{2.4} O _{0.8} (OH) _{0.1} (OH—H ₂ O _{ads}) _{0.4} F _{0.6} |
| (2.0) | (2.4) | (2.7) |
| ag-Ti ₂ C _{0.8} O _{0.4} (OH) _{0.6} (OH—H ₂ O _{ads}) _{0.3} F _{0.3} (2.0) | ag-Ti ₃ C _{1.8} O _{0.6} (OH) _{0.4} (OH—H ₂ O _{ads}) _{0.5} F _{0.3} (2.4) | ag-Nb ₄ C _{2.3} O _{0.9} (OH) _{0.35} (OH $-$ H ₂ O _{ads}) _{0.35} F _{0.7} (3.2) |
| ap-Nb ₂ CO _{0.8} (OH—H ₂ O _{ads}) _{0.5} F _{0.7} | ap-Ti ₃ CNO _{0.23} (OH) _{0.03} (OH—H ₂ O _{ads}) _{0.3} F _{1.3} (2.09) | |
| (2.8) ap-Nb ₂ C _{0.9} O _{0.6} (OH) _{0.01} (OH— H_2O_{ads}) _{0.3} F _{0.4} | (2.09) ap-Ti ₃ C _{0.9} N _{0.9} O _{0.5} (OH) _{0.07} (OH—H ₂ O _{ads}) _{0.3} F _{0.5} | |
| (1.91) | (1.87) | |
| ag-Nb ₂ CO _{1.1} (OH) _{0.2} (OH—H ₂ O _{ads}) _{0.4} F _{0.3} (3.1) | $\begin{array}{l} ag\text{-}Ti_3C_{0.6}N_{0.8}O_{0.4}(OH)_{0.6}(OHH_2O_{ads})_{0.6}F_{0.25}\\ (2.25) \end{array}$ | |

[‡] Before sputtering.

- (a) Before sputtering, most of the OH-terminations have adsorbed H₂O associated with them, *i.e.* moiety IV (yellow in Fig. 4) is prevalent. Sputtering and aging increase moiety II (gray in Fig. 4) at the expense of moiety IV.
- (b) The fraction of F-terminations moiety III (red in Fig. 4) is highest for the un-sputtered, freshly prepared samples. Sputtering and aging combined with sputtering increase moieties II and IV (hatched regions in Fig. 4) at the expense of moiety III. Note that the gray and blue colored cross-hatched regions in Fig. 4 represent OH-terminations.
- (c) The fraction of moiety I (blue in Fig. 4) for the as-prepared, unsputtered Ti-containing MXenes is about 0.3. Sputtering and aging combined with sputtering increase that fraction significantly. For example, in the Ti₃C₂T_x case, moiety I is doubled after sputtering. As noted above, aging and sputtering increase the OH-terminations at the expense of the F-terminations. A fraction of these OH-terminations are, in turn, strongly bonded to H₂O water molecules (blue hatched regions in Fig. 4). About 22 to 33 mole % of the Ti atoms are terminated with oxygen atoms (blue) and ≈17 mol% are F-terminated (red).
- (d) Replacing 50% of the C atoms by N atoms, led to a decrease in moiety I, a slight decrease in moiety III and a concomitant increase in OH-terminations (compare $ag-Ti_3C_2T_x$ and $ag-Ti_3CNT_x$ in Fig. 4).
- (e) For the un-sputtered, fresh, Nb-based MXenes, the major effect of increasing n, is the presence of a significantly higher fraction of the hydroxyl terminations (Table 5). For the Ti-based MXenes, increasing n, results in an increase in moiety I, while the combined total of moieties II and IV remains approximately the same.
- (f) For the un-sputtered, ap-Nb₄ C_3 T_x composition, the total number of moles for all terminations exceeds the maximum possible value of 2 (see Fig. 1b) assuming one termination per surface M atom by 0.6 mol [67]. The reason for this surface state is unclear, but it is possible that some of the terminating atoms end up occupying C-vacant sites. In this MXene, the fraction of -O (blue region in Fig. 4), -F (orange region in Fig. 4) and OH-terminations (hatched regions in Fig. 4) are roughly equal.
- (g) The fraction of oxygen terminations (moiety I) is highest in Nb_2CT_x (blue regions in Fig. 4). Those in $Nb_4C_3T_x$ are comparable to their Ti counterparts (compare blue regions in Fig. 4). Interestingly, a majority of the OH-terminations in Nb_2CT_x have strongly bonded water molecules attached to them.
- (h) With the notable exceptions of ap-Ti₃C₂T_x and ag-Nb₄C₃T_x, the fraction of F-terminations (orange regions in Fig. 4) is significantly lower than their —O or —OH counterparts.
- (i) With the exception of the Ti_2CT_x -based MXene, the general effect of sputtering is to decrease the X content below the value measured for the un-sputtered samples of the same

- composition. For example, the sputtered ap- $Ti_3C_2T_x$ and ap- Ti_3CNT_x sample are 10% deficient in X; and the sputtered ap- $Nb_4C_3T_x$ composition the C content drops from 2.6 to 2.4 after sputtering. As described below in Section 4, this most probably is due to Ar^+ ion beam damage, which selectively sputters C and N atoms from the lattice.
- (j) Finally, aging seems to reverse the aforementioned trend. In all cases, the X-deficiency after aging and sputtering is less than directly after sputtering of the fresh samples.

3.4. Global chemistries and effect of sputtering

Table 6 summarizes the global chemistries (including non-MXene species) as deduced from the XPS spectra, before and after sputtering. The most notable trend seen in these results is the reduction – by $\approx\!50\%$ in some cases – of the C signal and the subsequent increase in the M-signal upon sputtering. For example, for the ag-Ti₃C₂T_x sample, the Ti percentage increased from about 17 at.% before sputtering to 28 at.% after sputtering; concomitantly, the C percentage decreased from 33 to 16 at.%.

Spectra collected before sputtering for the fresh MXenes in this study show that the M:X ratio is the same as the theoretical ratio for all MXenes except Ti_2CT_x , which has a M:X ratio of 2:0.9 (10% deficiency in X). This deficiency might be due to preferential HFetching of the X element. After sputtering of fresh MXene samples, an increase in the M:X ratio is observed for all MXenes (except Ti_2CT_x) which is due to Ar^+ ion beam damage, selectively sputtering C atoms from the lattice. After sputtering, the aged MXenes in this study exhibit a further increase in the M:X ratio, compared to the fresh sputtered samples. For example, $ag-Ti_2CT_x$ has a M:X ratio of 2:0.8 (20% deficiency in X), $ag-Ti_3CNT_x$ has a M:X ratio of 3:1.2 (40% deficiency in X), and $ag-Nb_4C_3T_x$ has a M:X ratio of 4:2.3 (40% deficiency in X). This change in ratio may be attributable to a replacement of some of the C atoms in the MXenes sheets by O during oxidation.

To further explore the effect of sputtering, the moles of C and moles – per formula unit – of moieties I, II, III and IV in ap- ${\rm Ti}_3{\rm C}_2{\rm T}_x$, before and after ${\rm Ar}^+$ sputtering are plotted in Fig. 5. From these results it is obvious that the F-content is also reduced, with a concomitant increase in moiety I. There is also a decrease in the moles of ${\rm H}_2{\rm O}$ strongly adsorbed to the surface, *i.e.* moiety IV, (see Fig. 5). The same tendency can also be gleaned from comparing the derived formulae before $[{\rm Ti}_3{\rm C}_2{\rm O}_{0.3}({\rm OH})_{0.32}{\rm F}_{1.2}]$ and after $[{\rm Ti}_3{\rm C}_{1.8}{\rm O}_{0.6}({\rm OH})_{0.4}{\rm F}_{0.8}]$ sputtering. It is thus obvious that the reduction in moiety III is accompanied with an increase in moiety I. Said otherwise, neither the C-atoms in ap- ${\rm Ti}_3{\rm C}_2{\rm T}_x$ nor the F-terminations – *i.e.* moiety III – are immune to the sputtering procedure used in this work. The same analysis of other compositions is not possible, due to organic (ambient) contamination obscuring

Table 6Summary of global atomic percentages – including non-MXene entities – before and after sputtering.

| | Ti (at.%) | Nb (at.%) | C (at.%) | F (at.%) | O (at.%) | Al (at.%) | N (at.%) |
|-----------------------------------------------------------|----------------|----------------|----------------|----------------|----------------|---------------|----------------|
| ap-Ti ₃ C ₂ T _x (before) | 26.1 ± 0.1 | | 31.4 ± 0.2 | 25.5 ± 0.2 | 15.1 ± 0.2 | 1.9 ± 0.1 | <0.1 |
| $ap-Ti_3C_2T_x$ (after) | 34.1 ± 0.2 | | 23.7 ± 0.3 | 20.9 ± 0.2 | 18.0 ± 0.2 | 3.3 ± 0.2 | < 0.1 |
| $ag-Ti_3C_2T_x$ (before) | 16.8 ± 0.3 | | 33.4 ± 0.5 | 24.8 ± 0.4 | 20.1 ± 0.4 | 3.3 ± 0.6 | 1.6 ± 0.3 |
| $ag-Ti_3C_2T_x$ (after) | 28.4 ± 0.5 | | 16.2 ± 0.7 | 24.0 ± 0.5 | 26.4 ± 0.5 | 4.2 ± 0.6 | < 0.1 |
| $ap-Ti_2CT_x$ (before) | 27.2 ± 0.9 | | 39.4 ± 0.9 | 13.4 ± 0.6 | 20.0 ± 0.7 | <0.1 | < 0.1 |
| $ap-Ti_2CT_x$ (after) | 33.4 ± 0.9 | | 29.5 ± 0.9 | 13.7 ± 0.7 | 23.4 ± 0.9 | <0.1 | < 0.1 |
| $ag-Ti_2CT_x$ (before) | 19.3 ± 0.3 | | 31.1 ± 0.6 | 11.4 ± 0.4 | 34.9 ± 0.6 | 1.2 ± 0.7 | < 0.1 |
| $ag-Ti_2CT_x$ (after) | 33.7 ± 0.5 | | 15.8 ± 0.7 | 11.8 ± 0.5 | 35.5 ± 0.6 | 1.9 ± 0.7 | 1.3 ± 0.3 |
| $ap-Ti_3CNT_x$ (before) | 30.6 ± 1.8 | | 29.4 ± 1.1 | 16.1 ± 0.8 | 12.1 ± 0.7 | <0.1 | 11.8 ± 0.6 |
| $ap-Ti_3CNT_x$ (after) | 36.5 ± 1.5 | | 18.8 ± 1.0 | 13.4 ± 0.7 | 18.3 ± 1.0 | < 0.1 | 12.9 ± 0.7 |
| $ag-Ti_3CNT_x$ (before) | 20.5 ± 0.3 | | 20.1 ± 0.6 | 13.4 ± 0.5 | 38.0 ± 0.6 | 1.9 ± 0.5 | 6.1 ± 0.4 |
| $ag-Ti_3CNT_x$ (after) | 32.8 ± 0.5 | | 9.3 ± 0.6 | 15.1 ± 0.5 | 31.3 ± 0.6 | 1.5 ± 0.7 | 10.0 ± 0.5 |
| $ap-Nb_2CT_x$ (before) | | 25.0 ± 0.7 | 31.4 ± 0.9 | 12.6 ± 0.6 | 31.0 ± 0.8 | <0.1 | < 0.1 |
| $ap-Nb_2CT_x$ (after) | | 42.5 ± 0.9 | 24.3 ± 1.1 | 11.7 ± 0.5 | 35.1 ± 0.8 | <0.1 | < 0.1 |
| $ag-Nb_2CT_x$ (before) | | 16.0 ± 0.3 | 33.6 ± 0.8 | 15.1 ± 0.5 | 32.6 ± 0.6 | 1.2 ± 0.5 | 1.5 ± 0.6 |
| $ag-Nb_2CT_x$ (after) | | 38.8 ± 0.5 | 21.0 ± 1.0 | 9.5 ± 0.5 | 28.3 ± 0.7 | 1.4 ± 0.6 | < 0.1 |
| $ap-Nb_4C_3T_x$ (before) | | 25.3 ± 0.2 | 55.0 ± 1.0 | 4.2 ± 0.6 | 15.5 ± 0.7 | <0.1 | < 0.1 |
| $ap-Nb_4C_3T_x$ (after) | | 29.7 ± 0.4 | 52.3 ± 0.6 | 3.6 ± 0.4 | 14.4 ± 0.5 | <0.1 | < 0.1 |
| $ag-Nb_4C_3T_x$ (before) | | 10.8 ± 0.2 | 36.0 ± 1.0 | 21.7 ± 0.6 | 26.3 ± 0.7 | 5.0 ± 1.5 | < 0.1 |
| $ag-Nb_4C_3T_x$ (after) | | 39.9 ± 0.5 | 24.4 ± 0.7 | 7.3 ± 0.3 | 24.7 ± 0.5 | 3.7 ± 0.6 | <0.1 |

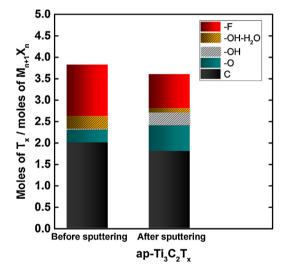


Fig. 5. Number of moles of C and moles of moieties I, II, III and IV, per $Ti_3C_2T_x$ formula unit, for the ap- $Ti_3C_2T_x$ sample before, and after, Ar sputtering.

relevant peaks, however a similar trend would be expected. Whether the entirety of the increase in M:F is due to preferential —F sputtering, or has some contribution from a decreased concentration of —F on the interior of the MXenes is unclear. Regardless, the C- and F-contents of sputtered samples reported herein most probably underestimate their true values.

The effects of sputtering on the fraction of the various oxides present in the various MXenes are plotted in Figs. S18 and S19. From these results it is clear that sputtering decreases the total fraction of Ti oxides and oxyflourides in the Ti-containing compositions (Fig. S18) and the Nb oxides and oxyflourides in the Nb-containing compositions (Fig. S19). Some MXenes appear to be more prone to oxidation than others. For example, sputter cleaning ag-Ti₃CNT $_X$ decreased the fraction of oxides from 88.3% to about 50.2%, compared to fractions of 48.3% and 34.6% for the ag-Ti₃C₂T $_X$ sample. No clear correlation was found between oxidation susceptibility and n or M.

Fig. S20a and b plot the atomic percentages of the various C species in the ap- and ag- $Ti_3C_2T_x$ samples before, and after, sputtering, respectively. From these results it is clear that the atomic percentages of the C-species associated with the ap- $Ti_3C_2T_x$ MXene structure, increase from ~ 54 at.% before, to ~ 85 at.% after sputtering

(Tables 2 and 3, Fig. S20a). In the case of the aged sample, the respective values are \sim 31 at.% to \sim 87 at.% (Tables S3 and S4, Fig. S20b). We note that the presence of a thin adventitious C film on the outermost surfaces of our pressed discs that were stored in air for a relatively long time is not too surprising. This is all confirmed by the fact that the fraction of adventitious C and hydrocarbons for the ap-Ti₃C₂T_x sample before sputtering was only 10%; after sputtering it was <1%. For all other MXenes the adventitious C and hydrocarbons concentrations were <2% after sputtering.

The effects of aging on the samples are demonstrated in Tables 5 and 6. It can be seen in Table 5 that upon aging, the amount of -F terminations are reduced for all of the MXenes, except $Nb_4C_3T_x$, which stays the same. Concomitantly, the amount of -OH terminations are increased for all of the MXenes during aging. When viewed from a stoichiometric perspective, the M:O ratio (with the O content derived from the sum of moieties I, II and IV) decreases for all of the MXenes as they age (Table 5). For example, the M:O ratio for ap- $Ti_3C_2T_x$ is 3:1, while the M:O ratio for ag-Ti₃C₂T_x is 3:1.5. These data indicate that as MXenes age, the surface chemistry changes as -F groups are predominately replaced with -OH groups. Note also, that the total number of moles for the various terminations gradually increases over time, indicating that oxidation of the MXenes begins as surface functionalization. As more evidence for this trend, the global (including non-MXene species) M:O ratio also decreases from 3:1.6 for ap- $Ti_3C_2T_x$ to 3:2.8 for ag- $Ti_3C_2T_x$ (Table 6). The change in the global M:O ratio for these samples indicates the uptake of oxygen over time as oxides are formed. Similar trends occur for all of the MXenes, though again, some seem to be more prone to oxidation than others. For example, the global M:O ratio for ap- Ti_2CT_x is 3:2.1 while the ratio for ag- Ti_2CT_x is 1:1.05. The fact that these trends are seen for all MXenes, however, clearly indicates the surface chemistry and global changes due to aging are processes that are ubiquitous.

Combined with the observation that sputtering decreases the amount of oxides, the oxygen and carbon data help to illustrate the overall framework of the aged MXene samples, wherein the MXene sits at the center of the grain, surrounded by a thin layer of oxides, which is then coated in a C-film. Graphitic carbon is present as a synthetic by-product as well, and likely helps to maintain conductive contact between MXene particles. The comparison between as-prepared and aged samples demonstrates that the use of MXene shortly after synthesis greatly reduces the amount of oxides and adventitious carbon present.

4. Discussion

Based on the totality of the results, summarized in Fig. 4 and Table 5, we conclude that the overall formulas for the Ti-containing MXenes - calculated without including the TiO₂ and other known oxide fractions – are $\text{Ti}_3\text{C}_2\text{O}_{0.3}(\text{OH})_{0.32}\text{F}_{1.2}$ and $Ti_3C_{1.8}O_{0.6}(OH)_{0.4}F_{0.8}$ for ap- $Ti_3C_2T_x$, before and after sputtering, respectively. For the sputtered samples measured after aging in air, the formulas are: $Ti_3C_{1.8}O_{0.6}(OH)_{0.9}F_{0.3}$, $Ti_2C_{0.8}O_{0.4}(OH)_{0.9}F_{0.3}$ and $Ti_3C_{0.6}N_{0.8}O_{0.4}(OH)_{1.2}F_{0.25}$. Interestingly, if one assumes the charge of -0 is -2, and those of -F and -0H are -1, then the average net negative charges of the surface terminations - shown in brackets below the formulas in Table 4 - for the Ti-based compounds are 2.15 ± 0.2 . In case of the Nb-containing MXenes, the average value is 2.9 ± 0.6 . This is an important result because it suggests that the $M_{n+1}X_n$ surface layers have a fixed net positive charge to which the composition of surface terminations must adjust to compensate and result in a neutral structure.

Recent X-ray absorption near edge structure (XANES) measurements have shown that the ${\rm Ti}_3{\rm C}_2{\rm T}_x$ spectra as quite comparable to those of TiO and that the average oxidation state of the Ti atoms was ≈ 2.4 [68]. Using this value – and assuming the oxidation states of the $-{\rm O}$, $-{\rm OH}$ and $-{\rm F}$ groups to be -2, -1 and -1, respectively – one can solve for the average oxidation states of the C atoms. Using the results shown in Table 4, the average C oxidation state in ${\rm Ti}_3{\rm C}_2{\rm T}_x$ is -2.6 ± 0.1 . Why this is the favored oxidation states is not clear at this time, but is a fruitful area of research for theoreticians. Similar calculations for the other compositions must await XANES measurements to determine the average M oxidation states.

From the results shown in Fig. 4, we conclude that the overall formulas for ag-Nb₂CT_x and ag-Nb₄C₃T_x - in the presence of Nb₂O₅ that is excluded from the analysis – are $Nb_2C_{0.9}O_{1.1}(OH)_{0.6}F_{0.3}$ and $Nb_4C_{2,3}O_{0,9}(OH)_{0,7}F_{0,7}$. Comparing these two compounds, it is obvious that the number of oxygen terminations per surface Nb atom in the former is slightly higher than in the latter. Conversely, the concentration of F-terminations, per surface Nb atom, is roughly half in the former than in the latter. The OH-terminations are more or less comparable. Looking at the adsorbed water component (yellow regions in Fig. 4), it is slightly larger in the ag-Nb₂CT_x case, compared to ag-Nb₄C₃T_x. These results are important because they confirm that what determines the terminations of a given MXene is not just the nature of the M-element, but also the number of those layers, viz. n in $M_{n+1}X_nT_x$. These comments notwithstanding (and as noted above), why the average moles of terminations is >2 is unclear at this time, but could be due to the diffusion of some terminations within the C-vacancies.

Post-synthesis, the dominant surface group on most MXenes is -F, viz. moiety III. This result is not surprising, given that HF is used for their production. However, another important result of this work is the instability of these F-terminations, as evidenced by the reduction in their concentrations after sputtering (Fig. 5, and Table 5), and upon aging (Table 5, and compare bars labeled ap- and ag-Ti₃C₂T_x in Fig. 4). The exchange of these -F groups for -OH as the samples age indicates that, in the presence of oxygen and/or water, the -OH termination is more favored, as predicted theoretically [69].

Based on our results it should be possible to tailor the surface terminations to suit the properties sought. For example, in some energy storage applications, OH terminations may be desirable, in others, not [69]. The fact that it is possible to tune, or control, the surface terminations is thus an important advance. For example, it was found in recent work that the replacement of F-terminations with —OH groups led to an increase in the electrochemical performance of a ${\rm Ti}_3{\rm C}_2{\rm T}_x$ -based supercapacitor [70]. The overall predisposition of Ti—MXenes to have —OH surface terminations is interesting, however, as it is the opposite of what is known

for TiC and TiO₂. TiC is known to react with water, dissociating the molecule into oxo groups [71]. Additionally, TiO₂ typically only contains \sim 25% –OH groups, which is less than the 39–50% observed herein for Ti₃C₂T_X and Ti₂CT_X [43].

5. Conclusions

Herein, we presented an in-depth analysis of the XPS spectra of the core levels of $Ti_3C_2T_x$, Ti_2CT_x , Ti_3CNT_x , Nb_2CT_x and $Nb_4C_3T_x$ cold pressed, 2D multilayered flakes. Before and after Ar^+ sputtering, the MXene surfaces are terminated by mixtures of -O, -F, and -OH, where a fraction of the latter are relatively strongly bonded to adsorbed H_2O molecules. For freshly prepared samples, -F is the predominant surface group. With time, the latter is gradually oxidized, leading to the formation of metal oxyfluorides and a decrease in their concentration. The MXenes, studied here, oxidize over time, as evidenced by an increase in oxygen content. Additionally, some MXenes are more prone to oxidation than others, displaying a large percentage of oxidation products when allowed to age in air.

The ap-Ti $_3$ C $_2$ T $_x$ compositions before and after sputtering were determined to be Ti $_3$ C $_2$ O $_0.3$ (OH) $_{0.32}$ F $_{1.2}$ and Ti $_3$ C $_{1.8}$ O $_{0.6}$ (OH) $_{0.4}$ F $_{0.8}$, respectively, indicating that sputtering selectively removes C from this MXene lattice, as well as reduces the concentration of F-terminations. The same holds true for ap-Ti $_3$ CNT $_x$ before and after sputtering, where their compositions were determined to be Ti $_3$ CNO $_{0.23}$ (OH—H $_2$ O $_{ads}$)O $_{0.3}$ F $_{1.3}$ and Ti $_3$ C $_{0.9}$ NO $_{0.9}$ O $_{0.5}$ (OH) $_{0.03}$ (OH—H $_2$ O $_{ads}$)O $_{0.3}$ F $_{0.5}$, respectively. Combining these results with recent XANES measurements, we conclude that the average oxidation states of the Ti and C atoms in the Ti $_3$ C $_2$ T $_x$ compositions are \approx +2.4 and \approx -2.6, respectively. It follows that the net charge on a MX block is positive and is neutralized by the adsorption of various negative terminations.

The ap-Ti₂CT_x compositions, before and after sputtering, however, were determined to be Ti₂C_{0.9}O_{0.3}(OH)_{0.1}(OH—H₂O_{ads})_{0.4}F_{0.8} and Ti₂C_{0.9}O_{0.5}(OH)_{0.1}(OH—H₂O_{ads})_{0.2}F_{0.7}, respectively. In this case, the major effect of sputtering is to convert some of the OH terminations to O. The overall formulas for the other aged MXenes, measured after sputtering, were determined to be Ti₃C_{1.8}O_{0.6}(OH)_{0.9}(F)_{0.3}, Ti₂C_{0.8}O_{0.4}(OH)_{0.9}(F)_{0.3}, Ti₃C_{0.6}N_{0.8}O_{0.4}(OH)_{1.2}(F)_{0.25}, Nb₂C_{0.9}O_{1.1}(OH)_{0.6}F_{0.3} and Nb₄C_{2.3}O_{0.9}(OH)_{0.7}F_{0.7}.

On the other hand, the freshly prepared Nb-based MXene chemistries, before sputtering were Nb₂CO_{0.8}(OH-H₂O_{ads})_{0.5}F_{0.7} and Nb₄C_{2.6}O_{0.9}(OH)_{0.1}(OH-H₂O_{ads})_{0.9}F_{0.7}.

Through this study, we were able to focus on the distribution of terminations for the various MXenes and the effect of changing several parameters such as the number of layers, M element and X element on the distribution of the terminations. In the case of Ti–MXenes, changing the number of layers, n, or the X element has little effect on the fraction of F-terminations. However, both of these factors affect the ratio of the -O to -OH terminations: increasing n from 1 to 2 leads to an increase in the -O to -OH ratio, while changing 50% of the X element causes the -O to -OH ratio to decrease. For the Nb–MXenes, the mole % of F-terminations doubles from Nb₄C₃T_x to Nb₂CT_x. The change in the -O to -OH ratio for the Nb–MXenes shows the opposite trend of the Ti–MXenes, as n increases, that ratio decreases.

When combined, these observations should impact the choice of the MXene to use for a specific application. The usefulness of quantifying under which conditions certain functional groups will be present on MXene surfaces is a significant development that will aid the design of any chemical systems that include these exciting and promising 2D compounds.

Acknowledgments

This work was supported by the European Research Council under the European Communities Seventh Framework Programme (FP7/2007–2013)/ERC Grant agreement no. [258509]. J. R. acknowledges funding from the Swedish Research Council (VR) grant no. 642-2013-8020 and from the KAW Fellowship program. The Swedish Foundation for Strategic Research (SSF) is acknowledged for support through the synergy grant FUNCASE and the Future Research Leaders 5 program. MN was partially sponsored by the Laboratory Directed Research and Development Program of Oak Ridge National Laboratory, managed by UT-Battelle, LLC, for the U. S. Department of Energy. We also acknowledge Dr. Jian Yang for providing Nb₄AlC₃ powders.

Appendix A. Supplementary data

Supplementary data associated with this article can be found, in the online version, at http://dx.doi.org/10.1016/j.apsusc.2015.11. 089.

References

- K.S. Novoselov, V.I. Fal'ko, L. Colombo, P.R. Gellert, M.G. Schwab, K. Kim, A roadmap for graphene, Nature 490 (2012) 192–200.
- [2] K.I. Bolotin, K.J. Sikes, Z. Jiang, M. Klima, G. Fudenberg, J. Hone, P. Kim, H.L. Stormer, Ultrahigh electron mobility in suspended graphene, Solid State Commun. 146 (2008) 351–355.
- [3] R.R. Nair, P. Blake, A.N. Grigorenko, K.S. Novoselov, T.J. Booth, T. Stauber, N.M. Peres, A.K. Geim, Fine structure constant defines visual transparency of graphene, Science 320 (2008) 1308.
- [4] L. Ci, L. Song, C. Jin, D. Jariwala, D. Wu, Y. Li, A. Srivastava, Z.F. Wang, K. Storr, L. Balicas, F. Liu, P.M. Ajayan, Atomic layers of hybridized boron nitride and graphene domains, Nat. Mater. 9 (2010) 430–435.
- [5] J.N. Coleman, M. Lotya, A. O'Neill, S.D. Bergin, P.J. King, U. Khan, K. Young, A. Gaucher, S. De, R.J. Smith, I.V. Shvets, S.K. Arora, G. Stanton, H.Y. Kim, K. Lee, G.T. Kim, G.S. Duesberg, T. Hallam, J.J. Boland, J.J. Wang, J.F. Donegan, J.C. Grunlan, G. Moriarty, A. Shmeliov, R.J. Nicholls, J.M. Perkins, E.M. Grieveson, K. Theuwissen, D.W. McComb, P.D. Nellist, V. Nicolosi, Two-dimensional nanosheets produced by liquid exfoliation of layered materials, Science 331 (2011) 568–571.
- [6] A.M. van der Zande, P.Y. Huang, D.A. Chenet, T.C. Berkelbach, Y. You, G.H. Lee, T.F. Heinz, D.R. Reichman, D.A. Muller, J.C. Hone, Grains and grain boundaries in highly crystalline monolayer molybdenum disulphide, Nat. Mater. 12 (2013) 554–561.
- [7] S. Najmaei, Z. Liu, W. Zhou, X. Zou, G. Shi, S. Lei, B.I. Yakobson, J.C. Idrobo, P.M. Ajayan, J. Lou, Vapour phase growth and grain boundary structure of molybdenum disulphide atomic layers, Nat. Mater. 12 (2013) 754–759.
- [8] R. Ma, T. Sasaki, Nanosheets of oxides and hydroxides: ultimate 2D charge-bearing functional crystallites, Adv. Mater. 22 (2010) 5082–5104.
- [9] V. Nicolosi, M. Chhowalla, M.G. Kanatzidis, M.S. Strano, J.N. Coleman, Liquid exfoliation of layered materials, Science 340 (2013), 1226419-1-1226419-18.
- [10] S. Stankovich, D.A. Dikin, R.D. Piner, K.A. Kohlhaas, A. Kleinhammes, Y. Jia, Y. Wu, S.T. Nguyen, R.S. Ruoff, Synthesis of graphene-based nanosheets via chemical reduction of exfoliated graphite oxide, Carbon 45 (2007) 1558–1565.
- [11] M.K. Kinyanjui, C. Kramberger, T. Pichler, J.C. Meyer, P. Wachsmuth, G. Benner, U. Kaiser, Direct probe of linearly dispersing 2D interband plasmons in a free-standing graphene monolayer, EPL 97 (2012) 57005.
- [12] Y. Liu, R. Willis, K. Emtsev, T. Seyller, Plasmon dispersion and damping in electrically isolated two-dimensional charge sheets, Phys. Rev. B: Condens. Matter Mater. Phys. 78 (2008) 201403.
- [13] A. Politano, A.R. Marino, V. Formoso, D. Farias, R. Miranda, G. Chiarello, Evidence for acoustic-like plasmons on epitaxial graphene on Pt(111), Phys. Rev. B: Condens. Matter Mater. Phys. 84 (2011) 033401.
- [14] E. Bekyarova, M.E. Itkis, P. Ramesh, C. Berger, M. Sprinkle, W.A. de Heer, R.C. Haddon, Chemical modification of epitaxial graphene: spontaneous grafting of aryl groups, J. Am. Chem. Soc. 131 (2009) 1336–1337.
- [15] D.R. Dreyer, S. Park, C.W. Bielawski, R.S. Ruoff, The chemistry of graphene oxide, Chem. Soc. Rev. 39 (2010) 228–240.
- [16] K.N. Kudin, B. Ozbas, H.C. Schniepp, R.K. Prud'homme, I.A. Aksay, R. Car, Raman spectra of graphite oxide and functionalized graphene sheets, Nano Lett. 8 (2008) 36–41.
- [17] M. Naguib, M. Kurtoglu, V. Presser, J. Lu, J.J. Niu, M. Heon, L. Hultman, Y. Gogotsi, M.W. Barsoum, Two-dimensional nanocrystals produced by exfoliation of Ti₃AlC₂, Adv. Mater. 23 (2011) 4248–4253.

- [18] M.W. Barsoum, MAX Phases: Properties of Machinable Ternary Carbides and Nitrides, John Wiley & Sons, Weinheim, Germany, 2013.
- [19] M. Ghidiu, M.R. Lukatskaya, M.Q. Zhao, Y. Gogotsi, M.W. Barsoum, Conductive two-dimensional titanium carbide 'clay' with high volumetric capacitance, Nature 516 (2014) 78–81.
- [20] M. Naguib, O. Mashtalir, J. Carle, V. Presser, J. Lu, L. Hultman, Y. Gogotsi, M.W. Barsoum, Two-dimensional transition metal carbides, ACS Nano 6 (2012) 1322–1331.
- [21] M. Naguib, J. Halim, J. Lu, K.M. Cook, L. Hultman, Y. Gogotsi, M.W. Barsoum, New two-dimensional niobium and vanadium carbides as promising materials for Li-ion batteries, J. Am. Chem. Soc. 135 (2013) 15966–15969.
- [22] J. Halim, M.R. Lukatskaya, K.M. Cook, J. Lu, C.R. Smith, L.A. Naslund, S.J. May, L. Hultman, Y. Gogotsi, P. Eklund, M.W. Barsoum, Transparent conductive two-dimensional titanium carbide epitaxial thin films, Chem. Mater. 26 (2014) 2374–2381.
- [23] M. Naguib, V.N. Mochalin, M.W. Barsoum, Y. Gogotsi, 25th anniversary article: MXenes: a new family of two-dimensional materials, Adv. Mater. 26 (2014) 992-1005.
- [24] M. Ghidiu, M. Naguib, C. Shi, O. Mashtalir, L.M. Pan, B. Zhang, J. Yang, Y. Gogotsi, S.J. Billinge, M.W. Barsoum, Synthesis and characterization of two-dimensional Nb₄C₃ (MXene), Chem. Commun. (Camb.) 50 (2014) 9517–9520.
- [25] B. Anasori, Y. Xie, M. Beidaghi, J. Lu, B.C. Hosler, L. Hultman, P.R. Kent, Y. Gogotsi, M.W. Barsoum, Two-dimensional, ordered, double transition metals carbides (MXenes), ACS Nano (2015), http://dx.doi.org/10.1021/acsnano. 5h03591
- [26] M. Naguib, J. Come, B. Dyatkin, V. Presser, P.L. Taberna, P. Simon, M.W. Barsoum, Y. Gogotsi, MXene: a promising transition metal carbide anode for lithium-ion batteries, Electrochem. Commun. 16 (2012) 61–64.
- [27] O. Mashtalir, M. Naguib, V.N. Mochalin, Y. Dall'Agnese, M. Heon, M.W. Barsoum, Y. Gogotsi, Intercalation and delamination of layered carbides and carbonitrides, Nat. Commun. 4 (2013) 1716.
- [28] Q. Tang, Z. Zhou, P. Shen, Are MXenes promising anode materials for Li ion batteries? Computational studies on electronic properties and Li storage capability of Ti₃C₂ and Ti₃C₂X₂ (X = F, OH) monolayer, J. Am. Chem. Soc. 134 (2012) 16909–16916.
- [29] J. Come, M. Naguib, P. Rozier, M.W. Barsoum, Y. Gogotsi, P.L. Taberna, M. Morcrette, P. Simon, A non-aqueous asymmetric cell with a Ti₂C-based two-dimensional negative electrode, J. Electrochem. Soc. 159 (2012) A1368–A1373.
- [30] M.R. Lukatskaya, O. Mashtalir, C.E. Ren, Y. Dall'Agnese, P. Rozier, P.L. Taberna, M. Naguib, P. Simon, M.W. Barsoum, Y. Gogotsi, Cation intercalation and high volumetric capacitance of two-dimensional titanium carbide, Science 341 (2013) 1502–1505.
- [31] O. Mashtalir, K.M. Cook, V.N. Mochalin, M. Crowe, M.W. Barsoum, Y. Gogotsi, Dye adsorption and decomposition on two-dimensional titanium carbide in agueous media. J. Mater. Chem. A 2 (2014) 14334–14338.
- aqueous media, J. Mater. Chem. A 2 (2014) 14334–14338.

 [32] Q. Peng, J. Guo, Q. Zhang, J. Xiang, B. Liu, A. Zhou, R. Liu, Y. Tian, Unique lead adsorption behavior of activated hydroxyl group in two-dimensional titanium carbide. I. Am. Chem. Soc. 136 (2014) 4113–4116.
- [33] X. Li, G. Fan, C. Zeng, Synthesis of ruthenium nanoparticles deposited on graphene-like transition metal carbide as an effective catalyst for the hydrolysis of sodium borohydride, Int. J. Hydrogen Energy 39 (2014) 14927–14934.
- [34] Z. Ling, C.E. Ren, M.-Q. Zhao, J. Yang, J.M. Giammarco, J. Qiu, M.W. Barsoum, Y. Gogotsi, Flexible and conductive MXene films and nanocomposites with high capacitance, Proc. Nat. Acad. Sci. 111 (2014) 16676–16681.
- [35] M. Naguib, R.R. Unocic, B.L. Armstrong, J. Nanda, Large-scale delamination of multi-layers transition metal carbides and carbonitrides "MXenes", Dalton Trans. 44 (2015) 9353–9358.
- [36] O. Mashtalir, M.R. Lukatskaya, M.Q. Zhao, M.W. Barsoum, Y. Gogotsi, Amine-assisted delamination of Nb₂C MXene for Li-ion energy storage devices, Adv. Mater. 27 (2015) 3501–3506.
- [37] S. Balendhran, S. Walia, H. Nili, S. Sriram, M. Bhaskaran, Elemental analogues of graphene: silicene, germanene, stanene, and phosphorene, Small 11 (2015) 640–652.
- [38] H.S. Liu, N.N. Han, J.J. Zhao, Atomistic insight into the oxidation of monolayer transition metal dichalcogenides: from structures to electronic properties, RSC Adv. 5 (2015) 17572–17581.
- [39] M. Naguib, O. Mashtalir, M.R. Lukatskaya, B. Dyatkin, C. Zhang, V. Presser, Y. Gogotsi, M.W. Barsoum, One-step synthesis of nanocrystalline transition metal oxides on thin sheets of disordered graphitic carbon by oxidation of MXenes, Chem. Commun. (Camb.) 50 (2014) 7420–7423.
- [40] H. Ghassemi, W. Harlow, O. Mashtalir, M. Beidaghi, M.R. Lukatskaya, Y. Gogotsi, M.L. Taheri, In situ environmental transmission electron microscopy study of oxidation of two-dimensional Ti₃C₂ and formation of carbon-supported TiO₂, J. Mater. Chem. A 2 (2014) 14339–14343.
- [41] Z. Li, L. Wang, D. Sun, Y. Zhang, B. Liu, Q. Hu, A. Zhou, Synthesis and thermal stability of two-dimensional carbide MXene Ti₃C₂, Mater. Sci. Eng., B 191 (2015) 33–40.
- [42] J. Li, Y. Du, C. Huo, S. Wang, C. Cui, Thermal stability of two-dimensional Ti₂C nanosheets, Ceram. Int. 41 (2015) 2631–2635.
- [43] S. Yamamoto, H. Bluhm, K. Andersson, G. Ketteler, H. Ogasawara, M. Salmeron, A. Nilsson, In situ X-ray photoelectron spectroscopy studies of

- water on metals and oxides at ambient conditions, J. Phys.—Condens. Matter 20 (2008) 184025.
- [44] C. Mousty-Desbuquoit, J. Riga, J.J. Verbist, Electronic structure of titanium(III) and titanium(IV) halides studied by solid-phase X-ray photoelectron spectroscopy, Inorg. Chem. 26 (1987) 1212–1217.
- [45] Y. Luo, P. Wang, L.P. Ma, H.M. Cheng, Hydrogen sorption kinetics of MgH₂ catalyzed with NbF₅, J. Alloys Compd. 453 (2008) 138–142.
- [46] J. Halbritter, A. Darlinski, Angle resolved XPS studies of oxides at Nb-, NbN-, NbC- and Nb₃Sn-surfaces, IEEE Trans. Magn. 23 (1987) 1381–1384.
- [47] M.T. Marques, A.M. Ferraria, J.B. Correia, A.M.B.d. Rego, R. Vilar, XRD, XPS and SEM characterisation of Cu–NbC nanocomposite produced by mechanical alloying, Mater. Chem. Phys. 109 (2008) 174–180.
- [48] V. Schier, H.J. Michel, J. Halbritter, ARXPS-analysis of sputtered TiC, SiC and Ti_{0.5}Si_{0.5}C layers, Fresenius J. Anal. Chem. 346 (1993) 227–232.
- [49] E. Lewin, M. Gorgoi, F. Schäfers, S. Svensson, U. Jansson, Influence of sputter damage on the XPS analysis of metastable nanocomposite coatings, Surf. Coat. Technol. 204 (2009) 455–462.
- [50] S. Myhra, J.A.A. Crossley, M.W. Barsoum, Crystal-chemistry of the Ti₃AlC₂ and Ti₄AlN₃ layered carbide/nitride phases—characterization by XPS, J. Phys. Chem. Solids 62 (2001) 811–817.
- [51] M.R. Lukatskaya, J. Halim, B. Dyatkin, M. Naguib, Y.S. Buranova, M.W. Barsoum, Y. Gogotsi, Room-temperature carbide-derived carbon synthesis by electrochemical etching of MAX phases, Angew. Chem. Int. Ed. Engl. 53 (2014) 4877–4880.
- [52] M. Naguib, J. Halim, J. Lu, K. Cook, L. Hultman, Y. Gogotsi, M.W. Barsoum, New two-dimensional niobium and vanadium carbides as promising materials for Li-ion batteries, J. Am. Chem. Soc. 135 (2013) 15966–15969.
- [53] G. Beamson, D. Briggs, High Resolution XPS of Organic Polymers: The Scienta ESCA300 Database, Wiley, Etobicoke, Ontario, Canada, 1992.
- [54] T. Sultana, G.L. Georgiev, G. Auner, G. Newaz, H.J. Herfurth, R. Patwa, XPS analysis of laser transmission micro-joint between poly(vinylidene fluoride) and titanium, Appl. Surf. Sci. 255 (2008) 2569–2573.
- [55] F. Santerre, M.A. El Khakani, M. Chaker, J.P. Dodelet, Properties of TiC thin films grown by pulsed laser deposition, Appl. Surf. Sci. 148 (1999) 24–33.
- [56] U. Diebold, TiO₂ by XPS, Surf. Sci. Spectra 4 (1996) 227.
- [57] T. Tanuma, H. Okamoto, K. Ohnishi, S. Morikawa, T. Suzuki, Partially fluorinated metal oxide catalysts for a Friedel–Crafts-type reaction of dichlorofluoromethane with tetrafluoroethylene, Catal. Lett. 136 (2009) 77–82
- [58] P.M. Jayaweera, E.L. Quah, H. Idriss, Photoreaction of ethanol on TiO₂(110) single-crystal surface, J. Phys. Chem. C 111 (2007) 1764–1769.

- [59] K.H. Ernst, D. Grman, R. Hauert, E. Hollander, Fluorine-induced corrosion of aluminum microchip bond pads—an XPS and AES analysis, Surf. Interface Anal. 21 (1994) 691–696.
- [60] I. Popova, V. Zhukov, J.T. Yates, Depth-dependent electrical impedance distribution in Al₂O₃ films on Al(111)-detection of an inner barrier layer, Langmuir 16 (2000) 10309–10314.
- [61] A. Dacca, G. Gemme, L. Mattera, R. Parodi, XPS analysis of the surface composition of niobium for superconducting RF cavities, Appl. Surf. Sci. 126 (1998) 219–230.
- [62] R. Romero, J.R. Ramos-Barrado, F. Martin, D. Leinen, Nb₂O₅ thin films obtained by chemical spray pyrolysis, Surf. Interface Anal. 36 (2004) 888–891.
- [63] L. Chen, Q.Q. Sun, J.J. Gu, Y. Xu, S.J. Ding, D.W. Zhang, Bipolar resistive switching characteristics of atomic layer deposited Nb₂O₅ thin films for nonvolatile memory application, Curr. Appl. Phys. 11 (2011) 849–852.
- [64] S.Q. Guo, X. Zhang, Z. Zhou, G.D. Gao, L. Liu, Facile preparation of hierarchical Nb₂O₅ microspheres with photocatalytic activities and electrochemical properties, J. Mater. Chem. A 2 (2014) 9236–9243.
- [65] C.F. Miller, G.W. Simmons, R.P. Wei, High temperature oxidation of Nb, NbC and Ni₃Nb and oxygen enhanced crack growth, Scr. Mater. 42 (2000) 227–232.
- [66] Z. Weibin, W. Weidong, W. Xueming, C. Xinlu, Y. Dawei, S. Changle, P. Liping, W. Yuying, B. Li, The investigation of NbO₂ and Nb₂O₅ electronic structure by XPS, UPS and first principles methods, Surf. Interface Anal. 45 (2013) 1206–1210.
- [67] Y. Xie, P. Kent, Hybrid density functional study of structural and electronic properties of functionalized $Ti_{n+1}X_n$ (X = C, N) monolayers, Phys. Rev. B: Condens. Matter Mater. Phys. 87 (2013) 235441.
- [68] M.R. Lukatskaya, S.-M. Bak, X. Yu, X.Q. Yang, M.W. Barsoum, Y. Gogotsi, Probing the mechanism of high capacitance in 2D titanium carbide using in situ X-ray absorption spectroscopy, Adv. Energy Mater. (2015), http://dx. doi.org/10.1002/aenm.201500589.
- [69] Y. Xie, M. Naguib, V.N. Mochalin, M.W. Barsoum, Y. Gogotsi, X. Yu, K.W. Nam, X.Q. Yang, A.I. Kolesnikov, P.R. Kent, Role of surface structure on Li-ion energy storage capacity of two-dimensional transition-metal carbides, J. Am. Chem. Soc. 136 (2014) 6385–6394.
- [70] Y. Dall'Agnese, M.R. Lukatskaya, K.M. Cook, P.-L. Taberna, Y. Gogotsi, P. Simon, High capacitance of surface-modified 2D titanium carbide in acidic electrolyte, Electrochem. Commun. 48 (2014) 118–122.
- [71] S.V. Didziulis, P. Frantz, S.S. Perry, O. El-bjeirami, S. Imaduddin, P.B. Merrill, Substrate-dependent reactivity of water on metal carbide surfaces, J. Phys. Chem. B 103 (1999) 11129–11140.